_ecture	Date	Topic	Assignments	Lab Training
1	9/23	Introduction to MEMS Overview of MEMS Fabrication	L-Edit Basics Due (10/7)	
2	9/28	Overview of MEMS Fabrication	Choose Groups for Project	
_	-,	l .	Lab Report #1 assigned (Due 10/19)	
3	9/30	Safety Class (meet in EII 1141)		
	3,30	Nanofab Tour		
4	10/5	Overview of Fabrication Process		Oxidation
	-5,5			Solvent Cleaning
5	10/7	Oxidation, Modeling	L-Edit Assignment Due	Lithography
	,		Design Mask for Process (Due 10/14	0 , ,
6	10/12	Lithography I	2 00.8.1.1.1.00.1.1.00.000 (2 0.0 20, 2 1.0	
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7	10/14	Etching I	Design HW #1 Assigned (Due 10/28)	Evaporator
	,		Mask Design Due for Process	Liftoff
8	10/19	Etching II	Lab Report #1 Due	PDMS
	,		Lab Report #2 Assigned (Due 11/4)	Plasma Bonding
9	10/21	Deposition	Las Report #2 / tosigned (But 11/1)	r idoma Bonamb
9	10/21	Берозіцоп		
10	10/26	Packaging	Final Lab report Assigned (Due 12/2)	Microfluidic
		Guest Lecture: Payam Bozorgi		Experiments
11	10/28	Deposition II/Doping	Design HW #1 Due	·
	', -	/Wafer Bonding		
12	11/2	Characterization		
	11,2	Characterization		
13	11/4	Accelerometer Case Study	Lab Report #2 Due	
		ŕ	TAKE HOME MIDTERM ASSIGNED	
			(Due 11/16)	
14	11/9	BioMEMS Case Study		
4.5	11/11	 	TAKE HOME MUDTEDNA D 44 /4 C.	
15	11/11	Holiday (Veterans Day)	TAKE HOME MIDTERM Due 11/16	
16	11/16	Power MEMS Case Study		
		·		
17	11/18	Optical MEMS Case Study		Outreach Project
18	11/23	MEMS Design Case Study		
	,	Guest Lecture: Prof. Turner		
19	11/30	Guest Lecture: TBA		
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20	12/2	Review		
		ESDAY DECEMBER 7 FROM 12-3P	М.	1